

## PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1  
Stylesheet Version v1.2

Assignment ID: PATI388917

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
ADVANTECH GLOBAL LTD	07/23/2024
RECEIVING PARTY DATA	
Company Name:	AGL OLED LIMITED
Street Address:	FLAT/RM AI 3/F MIRADOR MANSION 54-64 NATHAN ROAD
Internal Address:	TSIM SHA TSUI KL
City:	Hong Kong
State/Country:	CHINA
PROPERTY NUMBERS Total: 13	
Property Type	Number
Application Number:	10900501
Application Number:	10950646
Application Number:	10970382
Application Number:	10995682
Application Number:	10996142
Application Number:	11020907
Application Number:	11026365
Application Number:	11044140
Application Number:	11147508
Application Number:	12697398
Application Number:	12628605
Application Number:	12646134
Application Number:	16371588
CORRESPONDENCE DATA	
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<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
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PATENT

<b>Address Line 4:</b> Park City, UTAH 84098	
<b>ATTORNEY DOCKET NUMBER:</b>	T2874
<b>NAME OF SUBMITTER:</b>	Vanessa Mangum
<b>SIGNATURE:</b>	Vanessa Mangum
<b>DATE SIGNED:</b>	07/26/2024
<b>Total Attachments: 2</b> source=T2874_Assignment#page1.tiff source=T2874_Assignment#page2.tiff	

PATENT ASSIGNMENT

Docket  
Number

T2874.0

WHEREAS, ADVANTECH GLOBAL LTD (hereinafter referred to as "ASSIGNOR") having a place of business at COMMENCE CHAMBERS P.O. BOX 2208, ROAD TOWN TORTOLA, VIRGIN ISLANDS, BRITISH, is the owner of record of the entire right, title and interest in the U.S. patent applications and/or U.S. patents shown in Exhibit A (hereinafter referred to as "PATENT PROPERTIES");

WHEREAS, AGL OLED LIMITED (hereinafter referred to as "ASSIGNEE") having a place of business at the FLAT/RM A1 3/F MIRADOR MANSION 54-64 NATHAN ROAD TSIM SHA TSUI KL, Hong Kong China, desires to acquire the entire right, title and interest in said PATENT PROPERTIES and in the inventions associated therewith;

NOW, THEREFORE, for good and valuable consideration, the receipt and sufficiency of which are hereby acknowledged, the ASSIGNOR hereby assigns to the ASSIGNEE, the entire right, title and interest in said PATENT PROPERTIES and in the inventions associated therewith and in all divisions, continuations and continuations-in-part thereof said, and reissues, extensions and renewals of Letters Patent granted thereon, and in all Letters Patents issuing thereon in the United States.

ASSIGNOR hereby authorizes and requests the United States Patent & Trademark Office to issue any and all of said Letters Patent to the ASSIGNEE as the assignee of ASSIGNOR'S entire right, title and interest in and to the same, for the sole use and behoof of the ASSIGNEE, its successors, assigns, and legal representatives, to the full end of the term for which said Letters Patent may be granted.

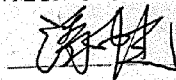
Further, ASSIGNOR agrees, without further consideration, to communicate to the ASSIGNEE any facts known to ASSIGNOR respecting said PATENT PROPERTIES and in the inventions associated therewith, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, continuation-in-part, substitute, renewal and reissue applications, execute all necessary assignment papers to cause said Letters Patent to be issued to the ASSIGNEE, make all rightful oaths, and, perform all lawful acts to aid the ASSIGNEE, its successors and assigns, to obtain and enforce Letters Patent for said invention in the United States.

ASSIGNOR

ADVANTECH GLOBAL LTD

Date: 07/23/2024

Signature:



Name 潘仲光

Title President

MASCHOFF BRENNAN, PLLC  
1389 CENTER DR., SUITE 300  
PARK CITY, UTAH 84098, USA

**Exhibit A**

<b>Title</b>	<b>APP. NO.</b>	<b>Filing Date</b>
TWO-LAYER SHADOW MASK WITH SMALL DIMENSION APERTURES AND METHOD OF MAKING AND USING SAME	10/900,501	2004-07-28
SYSTEM AND METHOD FOR ACTIVE ARRAY TEMPERATURE SENSING AND COOLING	10/950,646	2004-09-28
SYSTEM AND METHOD FOR COMPENSATION OF ACTIVE ELEMENT VARIATIONS IN AN ACTIVE-MATRIX ORGANIC LIGHT-EMITTING DIODE (OLED) FLAT-PANEL DISPLAY	10/970,382	2004-10-22
PATTERNING OF INDIUM-TIN OXIDE (ITO) FOR PRECISION-CUTTING AND ALIGNING A LIQUID CRYSTAL DISPLAY (LCD) PANEL	10/995,682	2004-11-23
MULTIPLE SHADOW MASK STRUCTURE FOR DEPOSITION SHADOW MASK PROTECTION AND METHOD OF MAKING AND USING SAME	10/996,142	2004-11-23
SYSTEM FOR AND METHOD OF FORMING VIA HOLES BY MULTIPLE DEPOSITION EVENTS IN A CONTINUOUS INLINE SHADOW MASK DEPOSITION PROCESS	11/020,907	2004-12-23
SYSTEM FOR AND METHOD OF FORMING VIA HOLES BY USE OF SELECTIVE PLASMA ETCHING IN A CONTINUOUS INLINE SHADOW MASK DEPOSITION PROCESS	11/026,365	2004-12-30
SYSTEM FOR AND METHOD OF PLANARIZING THE CONTACT REGION OF A VIA BY USE OF A CONTINUOUS INLINE VACUUM DEPOSITION	11/044,140	2005-01-27
SHADOW MASK DEPOSITION OF MATERIALS USING RECONFIGURABLE SHADOW MASKS	11/147,508	2005-06-08
METHOD AND APPARATUS FOR ELECTRONIC DEVICE MANUFACTURE USING SHADOW MASKS	12/697,398	2010-02-01
ELECTRONIC CIRCUIT WITH REPETITIVE PATTERNS FORMED BY SHADOW MASK VAPOR DEPOSITION AND A METHOD OF MANUFACTURING AN ELECTRONIC CIRCUIT ELEMENT	12/628,605	2009-12-01
SHADOW MASK DEPOSITION OF MATERIALS USING RECONFIGURABLE SHADOW MASKS	12/646,134	2009-12-13
Multi-Mask Alignment System and Method	16/371,588	2019-04-01